



Attorney's Docket No.: 12732-171001 / US6695

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Masaharu Nagai et al.

Art Unit : 1756

Serial No. : 10/694,986

Examiner : Daborah Chacko-Davis

Filed : October 29, 2003

Title : METHOD FOR REMOVING RESIST PATTERN AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

REPLY TO ACTION OF OCTOBER 4, 2005

Please amend the above-identified application as follows:

Amendments to the Claims begin on page 2.

Remarks begin on page 8.